

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:	Docket No.:	UTP-182US	
Meng Tao, et al.	Art Unit:	1794	
Serial No:	10/822,343	Examiner:	Speer, Timothy M.
Filed:	April 12, 2004	Conf. No.:	3111
For:	SUPPRESSION OF CHEMICAL REACTIVITY ON SEMICONDUCTOR SURFACES		

RESPONSE TO FINAL OFFICE ACTION MAILED AUGUST 1, 2008

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

In response to the Examiner's Final Office Action mailed August 1, 2008, please amend this application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.